

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

MANFRED HORSTMANN ROLF STEPHAN KARSTEN WIECZOREK STEPHEN KRUEGEL

Serial No.: 09/847,622

Filed: May 2, 2001

For: FIELD EFFECT TRANSISTOR WITH

REDUCED GATE DELAY AND METHOD OF FABRICATING THE

SAME

Examiner: Unknown

Group Art Unit: 2812

Att'y Docket: 2000.064200/DE0053

PRELIMINARY AMENDMENT

CERTIFICATE OF MAILING 37 C.F.R 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231. on the date below:

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

October 1, 2001

Date

Please amend the above-referenced patent application as follows:

IN THE CLAIMS:

Please amend claim 1 as follows:

1. (Amended) A transistor, comprising:

a substrate;

an active region defined in said substrate;

- a gate insulation layer formed above said active region; and
- a gate electrode formed above said gate insulation layer, said gate electrode having a middle portion located over the active region, said middle portion having a gate